

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		09/749,082	JENSEN ET AL.	
		Examiner	Art Unit	Page 1 of 1
		Beth Van Doren	3623	

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Cabot MMB enters CMP Market", Cabot Microelectronics Corp. Press Room, 07/12/1999 [retrieved 11/14/04], pages 1-2, retrieved from: google.com and archive.org.
	V	"Strasbaugh Symphony-CMP", www.strasbaugh.com, 04/28/1999 [retrieved 11/15/04], pages 1-8, retrieved from: Google.com and archive.org.
	W	DeJule, Ruth, "CMP grows in sophistication", Semiconductor International, 11/1998 [retrieved 11/15/04], Vol. 21, Issue 13, pages 1-5, retrieved from: Proquest Direct.
	X	DeJule, Ruth, "Advances in CMP", Semiconductor International, 11/1996 [retrieved 11/15/04], Vol. 19, Issue 12, pages 1-6, retrieved from: Proquest Direct.

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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